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PETE UNITED STATES PATENT AND TRADEMARK OFFICE

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Application No.:

09/744,877

Confirmation No.:

8711

Filing Date:

January 29, 2001

Inventor(s):

Halimaoui et al.

Title:

PROCESS FOR FORMING

AN OXIDE LAYER OF NON-

UNIFORM THICKNESS ON

THE SURFACE OF A

SILICON SUBSTRATE

Examiner:

Novacek, Christy L.

Group/Art Unit:

2822

Atty. Dkt. No:

5310-03000

CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8

DATE OF DEPOSIT:

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Commissioner for Patents

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AMENDMENT; RESPONSE TO FINAL OFFICE ACTION MAILED AUGUST 21, 2003

Mail Stop Non-Fee Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

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RECHNOLOGY CENTER 28

In response to the final Office Action mailed August 21, 2003 (Paper No. 15), Pease amend the above-specified application as follows:

Amendments to the claims are reflected in the listing of claims that begin on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.